

**AMENDMENTS TO THE CLAIMS:**

This listing of claims will replace all prior versions and listings of claims in the application:

1-18. (cancelled)

19. (previously presented) A film-forming apparatus, comprising:

a dispenser nozzle arranged to face a target substrate to be processed so as to supply a chemical solution that includes a solid component and a solvent to said target substrate;

a suction nozzle arranged to face said target substrate for selectively sucking only a solvent vapor on a liquid film formed on said target substrate by the supply of a chemical solution from said dispenser nozzle, wherein the length of a suction port of said suction nozzle in the longitudinal direction is larger than the diameter of said target substrate;

a first moving section for relatively moving said target substrate and said dispenser nozzle; and

a second moving section for relatively moving said target substrate and said suction nozzle.

20-25. (cancelled)

26. (new) The film-forming apparatus according to claim 19, further comprising a supply nozzle of gas flow for supplying a flow of gas to a liquid film formed on said target substrate.